



#17/6018
PATENT APPLICATION

6/10/03
C Moore

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date May 27, 2003

In re the Application of

Kiyoichi SUWA

Group Art Unit: 2818

Application No.: 09/729,339

Examiner: Q. Hoang

Filed: December 5, 2000

Docket No.: 108057

For: MASK, EXPOSURE METHOD, LINE WIDTH MEASURING METHOD, AND METHOD
FOR MANUFACTURING SEMICONDUCTOR DEVICES

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

RECEIVED
MAY 30 2003
TECHNOLOGY CENTER 2809

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired February 27, 2003, an extension of time for a period of three months is hereby requested. Attached hereto is our Check No. 142486 in the amount of \$930.00 in payment for:

<u> </u>	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u> </u>	Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
<u> X </u>	Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC/ccs

OLIFF & BERRIDGE, PLC
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Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
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